

# Bulk boron doping and surface carbon coating enabling fast-charging and stable Si anodes: from thin film to thick Si electrodes

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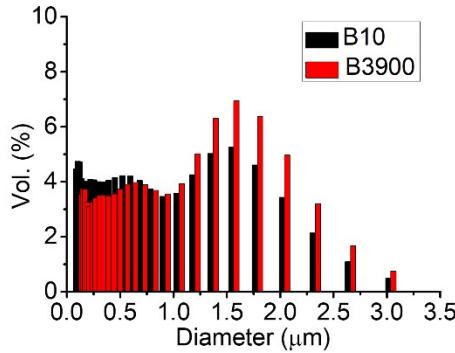


Fig. S1 The diameter distribution of as fabricated boron doped Si powders.

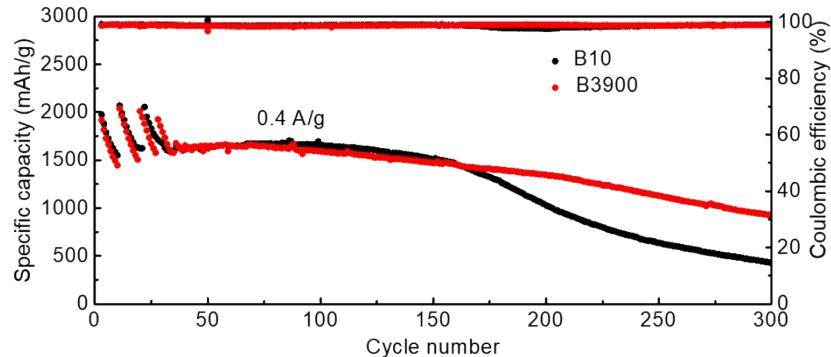


Fig. S2 The cycling performance of carbon coated boron doped Si electrodes at 0.4 A/g.

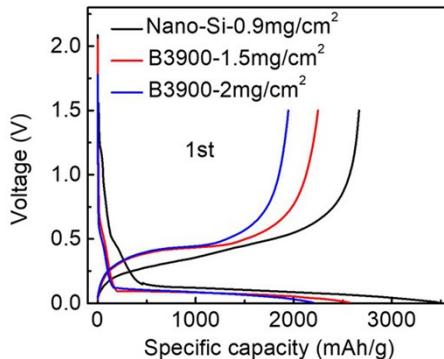


Fig. S3 The initail charge-discharge voltage profiles of Nano-Si, B3900 electrodes.

Table 1. Kinetics parameters of B10 and B3900 electrodes based on EIS data.

Sample	$R_e$ ( $\Omega$ )	$R_{ct}$ ( $\Omega$ )	$s$ ( $\text{cm}^2 \text{S}^{-0.5}$ )	$D_{\text{Li}^+}$ ( $\text{cm}^2 \text{S}^{-1}$ )
B10	2.62(4.19%)	13.32(8.89%)	38.78	$6.39 \times 10^{-12}$
B3900	2.16(1.96%)	7.42(8.41%)	32.69	$8.99 \times 10^{-12}$

Table 2. The diffusion coefficient evaluated by CV curves.

Sample	Slope	$D_{Li^+}$ (cm <sup>2</sup> S <sup>-1</sup> )
B10	2.89	$1.08 \times 10^{-12}$
B3900	7.97	$8.24 \times 10^{-12}$